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APPLICATION NO.	F	ILING DATE	FIRST NAMED INVENTOR Franz Laermer	ATTORNEY DOCKET NO. 10191/808	CONFIRMATION NO.
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KENYON & KENYON				EXAMINER	
ONE BROADWAY NEW YORK, NY 10004				OLSEN, ALLAN W	
				ART UNIT	PAPER NUMBER
				1763	$\overline{\Box}$
				DATE MAILED: 07/30/2003	/

Please find below and/or attached an Office communication concerning this application or proceeding.

3) Information Disclosure Statement(s) (PTO-1449) Paper No(s) 6.

Other:

Application/Control Number: 09/889,838

Art Unit: 1763

DETAILED ACTION

Claim Objections

Claims 15 and 21 are objected to because of the following informalities:

In the last two lines of claim 15, the words "is modulated" should be deleted;

In claim 21, "mHz" should be MHz". Appropriate correction is required.

Claim Rejections - 35 USC § 102

The following is a quotation of the appropriate paragraphs of 35 U.S.C. 102 that form the basis for the rejections under this section made in this Office action:

A person shall be entitled to a patent unless -

(b) the invention was patented or described in a printed publication in this or a foreign country or in public use or on sale in this country, more than one year prior to the date of application for patent in the United States.

Claims 15, 17-24 and 26-34 are rejected under 35 U.S.C. 102(b) as being anticipated by Kuwabara So et al. in Japanese Patent Publication 09-232738 (hereinafter, So).

So teaches etching a substrate with a plasma generated with energy coupled from 300 watts of 13.56 MHz RF energy. So teaches pulsing the 300 watts of 13.56 MHz RF power by on-off modulating the RF energy with an on-off, or pulsation frequency of 68 kHz. So teaches using a duty ratio of 50 % or a 1:1 mark-to-space ratio, wherein the packets of RF energy that are provided during the on periods have a square wave form. So teaches an additional layer of modulation such that the above described frequency modulation is subjected to a 1000 Hz on-off modulation with a 50 % duty ratio (or 1:1 mark-to-space ratio). See example 2, page 3 and figure 2a-2c.

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Claims 15-17, 20-23, 28, 29, 32-34 are rejected under 35 U.S.C. 102(b) as being anticipated by Mitsuta Yoshie et al. in Japanese Patent Publication 06-342770 (hereinafter, Yoshie).

Yoshie teaches a method for anisotropically etching silicon with a plasma generated with energy coupled from 180 watts of 13.56 MHz RF energy. Yoshie teaches pulsing the 180 watts of 13.56 MHz RF power by on-off modulating the RF power. Yoshie teaches using a duty ratio of 80 % or a 4:1 mark-to-space ratio. Yoshie teaches providing an additional layer of modulation such that the frequency modulation described above is further on-off modulated with a 67 % duty ratio (or 2:1 mark-to-space ratio). See page 4 paragraph [0020] and figure 3.

Allowable Subject Matter

Claims 25 and 35 are objected to as being dependent upon a rejected base claim, but would be allowable if rewritten in independent form including all of the limitations of the base claim and any intervening claims.

Conclusion

Any inquiry concerning this communication or earlier communications from the examiner should be directed to Allan Olsen whose telephone number is 703-306-9075. If attempts to reach the examiner by telephone are unsuccessful, the examiner's supervisor, Greg Mills, can be reached on 703-308-1633. The general fax numbers for TC1700 are 703-872-9310 (non-after finals) and 703-872-9311(after-final). Any inquiry of a general nature or relating to the status of this application or proceeding should be directed to the Group receptionist whose telephone number is (703) 308-0661.

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Allan Olsen, Ph.D. July 16, 2003